

EAST Search History

EAST Search History (Prior Art)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	0	(Polishing adj pad with (polyurethane polyolefin polyvinylalcohol polyvinylacetate polycarbonate (polyacrylic adj acid) polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyamide polyimide polytetrafluoroethylene polyetheretherketone)) and ("poisson's" adj ratio)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/24 15:08
S2	0	(Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones)) and ("poisson's" adj ratio)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/09/24 09:24
S3	6	("poisson's" adj ratio) with negative	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/09/24 09:25
S4	19	(US-6517417-\$ or US-6648733-\$ or US-6641471-\$ or US-6705934-\$ or US-6095902-\$ or US-6171181-\$ or US-6099954-\$ or US-6077785-\$ or US-6387312-\$ or US-6206759-\$ or US-6325703-\$ or US-6045716-\$). did. or (US-20030220061-\$ or US-20030003857-\$ or US-20020197935-\$ or US-20020077036-\$ or US-20030216111-\$ or US-20010024940-\$ or US-20010031610-\$).did.	US-PGPUB; USPAT	OR	OFF	2004/09/24 10:04
S5	13	((US-6517417-\$ or US-6648733-\$ or US-6641471-\$ or US-6705934-\$ or US-6095902-\$ or US-6171181-\$ or US-6099954-\$ or US-6077785-\$ or US-6387312-\$ or US-6206759-\$ or US-6325703-\$ or US-6045716-\$). did. or (US-20030220061-\$ or US-20030003857-\$ or US-20020197935-\$ or US-20020077036-\$ or US-20030216111-\$ or US-20010024940-\$ or US-20010031610-\$).did.) and density	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/05 14:41

S6	31	(Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones)) and density	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/09/24 10:05
S7	31	Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones) and density	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/09/24 10:08
S8	142	"poisson's" adj ratio	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/09/24 11:48
S9	2	((("4,668,557" or "4,688,557" or "5,196,353" or "5,284,435" or "5,314,512" or "5,391,516" or "5,433,651" or "5,489,233" or "5,609,511" or "5,643,046" or "5,658,183" or "5,739,642" or "5,838,447" or "5,872,633" or "5,893,796" or "5,949,927" or "5,964,643" or "6,062,968" or "6,126,532" or "6,203,407" or "6,454,634"),pn.) and ("poisson's" adj ratio)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/09/24 11:48
S10	40	((("4,668,557" or "4,688,557" or "5,196,353" or "5,284,435" or "5,314,512" or "5,391,516" or "5,433,651" or "5,489,233" or "5,609,511" or "5,643,046" or "5,658,183" or "5,739,642" or "5,838,447" or "5,872,633" or "5,893,796" or "5,949,927" or "5,964,643" or "6,062,968" or "6,126,532" or "6,203,407" or "6,454,634"),pn.) not (Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones))	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/09/24 11:51

S11	20	(Polishing adj pad) and (("4,668,557" or "4,688,557" or "5, 196,353" or "5,284,435" or "5,314,512" or "5,391,516" or "5,433,651" or "5,489,233" or "5,609,511" or "5,643,046" or "5,658,183" or "5,739,642" or "5,838,447" or "5,872,633" or "5,893,796" or "5,949,927" or "5,964,643" or "6,062,968" or "6,126,532" or "6,203,407" or "6,454,634").pn.)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/09/24 11:52
S13	46	Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/09/24 15:55
S14	1	((Polishing adj pad with (polyurethane polyolefin polyvinylalcohol polyvinylacetate polycarbonate (polyacrylic adj acid) polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyamide polyimide polytetrafluoroethylene polyetheretherketone)) or (Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones))) and (strain and ((bulk or ("Young's") or shear) adj modulus))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/09/24 16:16
S15	8	((Polishing adj pad with (polyurethane polyolefin polyvinylalcohol polyvinylacetate polycarbonate (polyacrylic adj acid) polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyamide polyimide polytetrafluoroethylene polyetheretherketone)) or (Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/09/24 16:17

		polyetheretherketones))) and (strain and ((bulk or ("Young's") or shear or elastic) adj modulus))				
S16	250	((Polishing adj pad with (polyurethane polyolefin polyvinylalcohol polyvinylacetate polycarbonate (polyacrylic adj acid) polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyamide polyimide polytetrafluoroethylene polyetheretherketone)) or (Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones))) and (strain or modulus)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 10:03
S17	115	((Polishing adj pad with (polyurethane polyolefin polyvinylalcohol polyvinylacetate polycarbonate (polyacrylic adj acid) polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyamide polyimide polytetrafluoroethylene polyetheretherketone)) or (Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones))) and (strain or ((bulk or ("Young's") or shear) adj modulus))	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 10:06
S18	168	((Polishing adj pad with (polyurethane polyolefin polyvinylalcohol polyvinylacetate polycarbonate (polyacrylic adj acid) polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyamide polyimide polytetrafluoroethylene polyetheretherketone)) or (Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 10:06

		polytetrafluoroethylenes polyetheretherketones))) and (modulus)				
S19	40	("4,668,557" or "4,688,557" or "5,196,353" or "5,284,435" or "5,314,512" or "5,391,516" or "5,433,651" or "5,489,233" or "5,609,511" or "5,643,046" or "5,658,183" or "5,739,642" or "5,838,447" or "5,872,633" or "5,893,796" or "5,949,927" or "5,964,643" or "6,062,968" or "6,126,532" or "6,203,407" or "6,454,634").pn.	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 14:28
S20	655	(Polishing adj pad with ((void adj voume) or (pore adj (density or diameter)) or grooves))	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 15:05
S21	0	(Polishing adj pad with (void adj voume))	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 15:50
S22	912	(Polishing adj pad with groove\$)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 15:06
S23	13	(Polishing adj pad with (pore adj (density or diameter)))	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 15:06
S24	9	(Polishing adj pad with (linear adj groove\$))	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 15:13
S25	13	(Polishing adj pad with (void adj volume))	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/05 13:53
S26	5	((Polishing adj pad with (pore adj (density or diameter)))) and ((Polishing adj pad with (void adj volume)))	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 15:52
S27	135	((((Polishing adj pad with (polyurethane polyolefin polyvinylalcohol polyvinylacetate polycarbonate (polyacrylic adj acid) polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyamide polyimide polytetrafluoroethylene polyetheretherketone)) or (Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones))) and (modulus)) not (((Polishing adj pad with (polyurethane polyolefin polyvinylalcohol polyvinylacetate polycarbonate (polyacrylic adj acid)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/05 08:51

		polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyamide polyimide polytetrafluoroethylene polyetheretherketone)) or (Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones))) and (strain or ((bulk or ("Young's" or shear) adj modulus)))				
S28	319	Elastollan C-64D	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/05 08:52
S29	0	"Elastollan C-64D"	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/05 08:51
S30	0	Elastollan and "C-64D"	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/05 08:52
S31	319	Elastollan	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/05 08:54
S32	1	Elastollan and (polishing adj pad)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/05 08:55
S33	26	(Polishing adj pad with (in adj situ))	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/05 13:53
S34	14	(Polishing adj pad with (in adj situ)) and (transparent lense transmissive optic\$ plug)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/05 13:55
S35	0	"20020182866".URPN.	USPAT	OR	OFF	2004/10/05 14:23
S36	0	"20020182866".URPN.	USPAT	OR	OFF	2004/10/05 14:24
S37	0	"20020182866".URPN.	USPAT	OR	OFF	2004/10/05 14:24
S38	2	"6095902".pn.	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/06 09:42
S39	2	"6126532".pn.	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/06 09:38
S40	1	"5893796".pn. and wavelength	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/06 09:39
S41	2	"6120353".pn.	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/06 10:15

S42	1	"5949927".pn. and pad	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/06 10:15
S44	25	("451".clas.) and ("re-entrant" or auxetic)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/11/29 13:52
S45	4	(polishing adj pad) and ("re-entrant" or auxetic)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/11/29 13:56
S46	40	auxetic	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/11/29 13:56
S47	2034	Polishing adj pad with (polyurethane polyolefin polyvinylalcohol polyvinylacetate polycarbonate (polyacrylic adj acid) polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyamide polyimide polytetrafluoroethylene polyetheretherketone)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/11/29 15:07
S48	1	10/754390.app.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/23 15:13
S49	627	(polishing adj pad) and ((expand\$4 near20 expand\$4) or (contract\$4 near20 contract\$4) or (compres\$6 near20 compres\$6))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/24 15:09
S50	210	(polishing adj pad) same ((expand \$4 near20 expand\$4) or (contract \$4 near20 contract\$4) or (compres \$6 near20 compres\$6))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/24 15:17
S51	11	(polishing adj pad) and Poisson\$4	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/24 15:37
S52	9	(polishing adj pad) and (("anti- rubber" or (anti near rubber)) or dilation\$6 or auxetic\$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/24 15:46
S53	57	(CMP "chemical mechanical polishing" "chemical mechanical planarizing") and (("anti-rubber" or (anti near rubber)) or dilation\$6 or auxetic\$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/24 15:44
S54	0	(CMP "chemical mechanical polishing" "chemical mechanical planarizing") and (auxetic\$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/24 15:43
S55	57	(CMP "chemical mechanical polishing" "chemical mechanical planarizing") and (dilation\$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/24 15:44
S56	0	(CMP "chemical mechanical polishing" "chemical mechanical planarizing") and ("anti-rubber" or (anti near rubber))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/24 15:44
S57	0	(CMP "chemical mechanical polishing" "chemical mechanical planarizing") and (dilation)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/24 15:44

S58	417	hysteresis and Poisson\$5	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/24 15:46
S59	207	hysteresis and Poisson\$5 and negative	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/24 15:48
S60	124	S59 and ((polishing adj pad) CMP "Chemical mechanical polishing" "Chemical mechanical" wafer substrate semiconductor\$4)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 11:04
S61	0	S59 and (polishing adj pad)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/24 15:48
S62	22	hysteresis and (Poisson\$5 with negative)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/24 16:26
S63	227	(Poisson\$5 with negative)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/24 16:26
S64	114	(Poisson\$5 near2 negative)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/24 16:26
S65	36	S64 and ((polishing adj pad) CMP "Chemical mechanical polishing" "Chemical mechanical" wafer substrate semiconductor\$4)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 09:10
S66	8	("re-entrant" or reentrant or auxetic) and (polishing adj pad)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 09:16
S67	409	("re-entrant" or reentrant or auxetic) and (CMP "chemical mechanical polishing" "chemical mechanical planarizing")	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 09:17
S68	326	("re-entrant" or auxetic) and (CMP "chemical mechanical polishing" "chemical mechanical planarizing")	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 09:18
S69	0	(auxetic) and (CMP "chemical mechanical polishing" "chemical mechanical planarizing")	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 09:17
S70	95	((("re-entrant" or auxetic) and (CMP "chemical mechanical polishing" "chemical mechanical planarizing")) not ("re-entrant" near6 (trench angle angles trenches))	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 09:24
S71	32	((negative near2 Poisson\$4) or auxetic or auxetic\$4 or dilational or (anti adj rubber) or "anti-rubber") with (properties property)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 09:25
S72	46	((negative near2 Poisson\$4) or auxetic or auxetic\$4 or dilational or (anti adj rubber) or "anti-rubber") with (properties property advantag \$4)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 09:26

S73	0	((negative near2 Poisson\$4) or auxetic or auxetic\$4 or dilatational or (anti adj rubber) or "anti-rubber") with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 09:39
S74	30	((negative near2 Poisson\$4) or auxetic or auxetic\$4 or dilatational or (anti adj rubber) or "anti-rubber") with (polymer)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 09:40
S75	33	((negative near2 Poisson\$4) or auxetic or auxetic\$4 or dilatational or (anti adj rubber) or "anti-rubber") with (polymer polymers polymeric)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 10:12
S76	16	S75 and S72	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 10:12
S77	0	(polishing adj pad) same (polymeric adj foam) and strength and (abrasion adj resist\$4) and (tear adj resist\$4)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 11:05
S78	0	(polishing adj pad) same (polymeric adj foam) and strength and (abrasion adj resist\$4)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 11:06
S79	5	((polishing adj pad) same polymer same foam) and strength and (abrasion adj resist\$4)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 11:12
S80	5	((polishing adj pad) same polymer \$2 same foam) and strength and (abrasion adj resist\$4)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 11:12
S81	20	(polishing adj pad) and (polymer\$2 same foam) and strength and (abrasion adj resist\$4)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/11/14 11:13
S82	0	("volumetric compression ratio") and (polishing adj pad)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 11:28
S83	0	(volum\$6 near3 compression near3 ratio) and (polishing adj pad)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 11:29
S84	23	(polishing adj pad) and (\$polyester \$4 same foam) and strength and (abrasion adj resist\$4)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/25 13:08
S85	2	"4668557".pn.	US-PGRUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	OFF	2006/05/26 11:06
S86	1	10/457316.app.	US-PGRUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	OFF	2006/05/26 11:07

S87	9	((polyester adj foam) and ((polishing planarizing) adj pad\$1)	US-PGRUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	OFF	2006/05/26 12:13
S88	75	((polishing planarizing) adj pad\$1) and ((polyester and (polyurethane \$4 polyolefin\$4)) with foam) and abrasive	US-PGRUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	OFF	2006/05/26 11:16
S89	45	((polishing planarizing) adj pad\$1) and ((polyester and (polyurethane \$4 polyolefin\$4)) with foam) and abrasive and (CMP "chemical mechanical polishing" "chemical mechanical planarizing")	US-PGRUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	OFF	2006/05/26 11:18
S90	45	((polishing planarizing) adj pad\$1) and (polyester with foam) and ((polyurethane\$4 polyolefin\$4) with foam) and abrasive and (CMP "chemical mechanical polishing" "chemical mechanical planarizing")	US-PGRUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	OFF	2006/05/26 11:18
S91	2	"6656018".pn.	US-PGRUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	OFF	2006/05/26 12:02
S92	308	((polyester adj foam) with polyurethane	US-PGRUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	OFF	2006/05/26 12:02
S93	6	((polyester adj foam) with polyurethane with based	US-PGRUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	OFF	2006/05/26 12:02
S94	52	((polyester near4 foam) and ((polishing planarizing) adj pad\$1)	US-PGRUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	OFF	2006/05/26 12:13
S95	17	((polyester near4 foam) and ((polishing planarizing) adj pad\$1) and (CMP "chemical mechanical polishing" "chemical mechanical planarizing")	US-PGRUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	OFF	2006/05/26 12:13
S96	27	((polishing adj pad) and (polymer\$2 same foam) and (abrasion adj resist \$4)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/11/14 11:14
S97	27	((polishing adj pad) and (polymer\$2 same foam) and (abrasion near resist\$4)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2007/06/29 09:18
S98	2	"4668557".pn.	US-PGRUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	OFF	2007/04/23 15:02
S99	38	((polishing adj pad) and ((polyester \$4 polyether\$4) same foam) and (abrasion near resist\$4)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2007/06/29 10:53
S100	35	((polishing adj pad) and (polymer\$2 same foam) and (abrasion near resist\$4)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2007/06/29 09:18

S101	8	S99 not S100	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2007/06/29 09:25
S102	0	EO02/46283	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2007/06/29 09:26
S103	1	WO02/46283	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2007/06/29 09:26
S104	68	(polishing adj pad) same (abrasion near resist\$4)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2007/06/29 10:54
S105	36	(polishing adj pad) with (abrasion near resist\$4)	US-PGRUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2007/06/29 10:54
S106	3517627	WO "2003058698"	US-PGRUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	OFF	2009/04/22 09:38
S107	1	WO adj "2003058698"	US-PGRUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	OFF	2009/04/22 09:38

EAST Search History (Interference)

<This search history is empty>

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